

Search Notes

Application/Control No.

10/711,111

Examiner

Jacob Y. Choi

Applicant(s)/Patent under
Reexamination

HEITLAUF, VIVienne M.

Art Unit

2875

SEARCHED

Class	Subclass	Date	Examiner
362	103, 249, 806, 808, 396, 122	9/18/2006	JC
362	124, 396	9/18/2006	JC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Class/Subclass (e.g, including class 24, 428, 446) & Text Search Conducted by Examiner	9/18/2006	JC